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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/796,146	03/10/2004	Mizuhisa Nihei	040102	2043
23850 7590 12/13/2007 KRATZ, QUINTOS & HANSON, LLP			EXAMINER	
1420 K Street, N.W. Suite 400	PHAM, THANHHA S			
WASHINGTO	N, DC 20005		ART UNIT	PAPER NUMBER
			2813	
			MAIL DATE	DELIVERY MODE
			12/13/2007	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

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,	Application No.	Applicant(s)			
	10/796,146	NIHEI ET AL.			
Office Action Summary	Examiner	Art Unit			
	Thanhha Pham	2813			
The MAILING DATE of this communication ap Period for Reply	opears on the cover sheet w	vith the correspondence address			
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING IF Extensions of time may be available under the provisions of 37 CFR 1 after SIX (6) MONTHS from the mailing date of this communication. If NO period for reply is specified above, the maximum statutory period Failure to reply within the set or extended period for reply will, by statu Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUN .136(a). In no event, however, may a d will apply and will expire SIX (6) MO tte, cause the application to become A	ICATION. I reply be timely filed INTHS from the mailing date of this communication. ABANDONED (35 U.S.C. § 133).			
Status					
1)⊠ Responsive to communication(s) filed on 18.	September 2007.				
3) Since this application is in condition for allow	ance except for formal ma	tters, prosecution as to the merits is			
closed in accordance with the practice under	Ex parte Quayle, 1935 C.	D. 11, 453 O.G. 213.			
Disposition of Claims					
4)⊠ Claim(s) <u>1-17 and 21-32</u> is/are pending in the	e application.	•			
4a) Of the above claim(s) 11-17 and 21-29 is/	• •	leration.			
5) Claim(s) is/are allowed.	•				
6)⊠ Claim(s) <u>1,7-10 and 30-32</u> is/are rejected.					
7)⊠ Claim(s) <u>2-6</u> is/are objected to.					
8) Claim(s) are subject to restriction and/	or election requirement.				
Application Papers					
9) The specification is objected to by the Examir	ner.				
10) The drawing(s) filed on is/are: a) ac		by the Examiner.			
Applicant may not request that any objection to the	•	•			
Replacement drawing sheet(s) including the corre	ction is required if the drawing	g(s) is objected to. See 37 CFR 1.121(d).			
11) The oath or declaration is objected to by the E	Examiner. Note the attache	ed Office Action or form PTO-152.			
Priority under 35 U.S.C. § 119					
12) Acknowledgment is made of a claim for foreig a) All b) Some * c) None of:	n priority under 35 U.S.C.	§ 119(a)-(d) or (f).			
1. Certified copies of the priority documer					
2. Certified copies of the priority documer					
3. Copies of the certified copies of the pri	•	n received in this National Stage			
application from the International Bures	,	t manaissad			
* See the attached detailed Office action for a lis	st of the certified copies no	t received.			
	·				
Attachment(s)	المائية ما الم	Summary (PTO-413)			
Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No	(s)/Mail Date			
3) Information Disclosure Statement(s) (PTO/SB/08) Paper No(s)/Mail Date	5) Notice of Other:	Informal Patent Application			

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DETAILED ACTION

This Office Action is in response to Applicant Amendment dated 09/18/2007.

Claim Rejections - 35 USC § 112

The following is a quotation of the second paragraph of 35 U.S.C. 112:

The specification shall conclude with one or more claims particularly pointing out and distinctly claiming the subject matter which the applicant regards as his invention.

- 1. Claims 7-10 and 31-32 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.
- With respect to claim 7,

line 2, the limitation "a first and a second upper surface" renders the claim indefinite. It is not clear what "a first and a second upper surface" means. It is not clear how a first surface is defined – a first upper surface being the same side with the second upper surface? Applicant is respectfully suggest to clarify and use appropriate better claimed language.

With respect to claim 9,

Limitation "the second surface" lacks antecedent basic.

With respect to claim 10,

line 2, the limitation "a first and a second upper surface" renders the claim indefinite. It is not clear what "a first and a second upper surface" means. It is not clear how a first surface is defined – a first upper surface being the same side

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with the second upper surface? Applicant is respectfully suggest to clarify and use appropriate better claimed language.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 1. Claims 1, 7, 8 and 10 are rejected under 35 U.S.C. 102(b) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over Chen [US 6,191,478].
- ► With respect to claim 1, Chen (fig 5 & 8, cols 1-8) discloses the claimed semiconductor device comprising:
 - a SiC substrate (25, silicon carbide, col 5 lines 15-21); and
- a heat conductor (33, col 5 lines 4-38) formed in a first hole (27) in the SiC substrate and made of linear structure of carbon elements (carbon fiber) inherently oriented in a depth direction of the first hole wherein the linear structure of carbon elements is a bundle of carbon nanotubes (carbon fibers in the first hole would oriented in a depth direction of the first hole and is a bundle of carbon nanotubes)

wherein a diameter of the heat conductor is the same as a diameter of the first hole.

▶ With respect to claim 7, Chen (fig 5, 7 & 8, cols 1-8) discloses the claimed semiconductor device comprising:

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a SiC substrate (25, silicon carbide, col 5 lines 15-21)having a first surface upper surface and a second upper surface;

a first heat conductor (33a, col 5 lines 4-38) formed in a first hole (27a, col 8 lines 38-55) in the first surface of the SiC substrate and made of linear structure of carbon elements (carbon fiber);

a second heat conductor (33b, col 5 lines 4-38) formed in a second hole (27b) in the first surface of the SiC substrate and made of linear structure of carbon elements (carbon fiber) inherently oriented in a depth direction of the second hole wherein the linear structure of carbon elements is a bundle of carbon nanotubes (carbon fibers in the first hole would oriented in a depth direction of the first hole and is a bundle of carbon nanotubes); and

an element (61, fig 7) formed on the second surface of the SiC substrate, wherein a diameter of the first heat conductor is the same as a diameter of the first hole and a diameter of the second heat conductor is the same as a diameter of the second hole.

▶ With respect to claim 8, the claimed distance from the second upper surface of the SiC substrate to an upper surface of the second heat conductor relative (longer) to a distance from the second upper surface of the SiC substrate to an upper surface of the first heat conductor would have been obvious to an ordinary artisan practicing the invention because, absent evidence of disclosure of criticality for the range giving unexpected results, it is not inventive to discover optimal or workable ranges by routine experimentation. In re Aller, 220 F.2d 454, 105 USPQ 233, 235 (CCPA 1955).

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Furthermore, it appears that these changes produce no functional differences and therefore would have been obvious. See In re Woodruff, 919 F.2d 1575, 1578, 16 USPQ2d 1934, 1936 (Fed. Cir. 1990).

▶ With respect to claim 10, Chen (fig 5, 7 & 8, cols 1-8) discloses the claimed semiconductor device comprising:

a SiC substrate (25, silicon carbide, col 5 lines 15-21) having a first upper surface (the surface of the substrate 25 that defines hole 27b -- wall and bottom of hole 27b) and a second upper surface;

a first heat conductor (33a, col 5 lines 4-38) formed in a hole (27a, col 8 lines 38-55) in the first surface of the SiC substrate and made of linear structure of carbon elements (carbon fiber) inherently oriented in a depth direction of the hole wherein the linear structure of carbon elements is a bundle of carbon nanotubes (carbon fibers in the first hole would oriented in a depth direction of the hole and is a bundle of carbon nanotubes);

a second heat conductor (33b, col 5 lines 4-38) formed to cover the upper first surface of the SiC substrate entirely (second heat conductor 33b filling hole 27b would inherently entirely cover the first surface since the first surface of the substrate 25 is the surface that define the hole 27b) in the first surface of the SiC substrate and made of linear structure of carbon elements (carbon fiber) oriented in a depth direction of the hole; and

an element (61, fig 7) formed on the second upper surface of the SiC substrate, wherein a diameter of the first heat conductor is the same as a diameter of the hole.

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Allowable Subject Matter

2. Claim 2-6 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Response to Arguments

3. Applicant's arguments with respect to claims 1, 7-10 and 30-32 have been considered but are most in view of the new ground(s) of rejection.

Conclusion

4. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thanhha Pham whose telephone number is (571) 272-1696. The examiner can normally be reached on Monday and Thursday 9:00AM - 9:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Carl Whitehead Jr can be reached on (571) 272-1702. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

TSP

THANHHA S. PHAM PRIMARY EXAMINER